

**Notice of References Cited**

Application/Control No.

10/010,850

Applicant(s)/Patent Under  
Reexamination  
CLEWS ET AL.

Examiner

Binh X Tran

Art Unit

1765

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,605,230	08-2003	Liaw et al.	216/104
	B	US-6,479,395	11-2002	Smith et al.	438/723
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Gennissen et al., "Sacrificial Oxide Etching Compatible with Aluminum Metallization", Proceedings of the 1997 International Conference on Solid-state Sensors and Actuators, Transducer '97, pp. 225-228, June 16-19, 1997.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.